

Attorney Docket: 071469-0309182
Client Reference: PC6042A2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

Confirmation Number: 8235

PANDA SIDDHARTHA , ET AL.

Application No.: 10/821,201

Group Art Unit: 1763

Filed: April 9, 2004

Examiner: George A. GOUDREAU

Title: METHOD AND SYSTEM FOR DEEP TRENCH SILICON ETCH

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 29, 2008, the period for reply being extended by the Petition for Three-Month Extension of Time filed herewith, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.